

Notice of References Cited		Application/Control No. 10/565,585	Applicant(s)/Patent Under Reexamination OKOROAFOR, EMMANUEL UZOM	
		Examiner EDNA WONG	Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0149759	08-2004	Moser et al.	220/581
*	B	US-5,811,194	09-1998	Kurze et al.	428/469
*	C	US-6,655,937	12-2003	Hasert et al.	418/152
*	D	US-4,647,347	03-1987	Schoener et al.	427/419.2
*	E	US-3,971,710	07-1976	Romankiw, Lubomyr T.	428/620
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 02088593 A1	11-2002	World Intellect	MOSER E M et al.	F17C 1/16
	O	JP 54031479 A	03-1979	Japan	MORIO TADAMITSU	C08J 7/07
*	P	RU 2026890 C1	01-1995	Russian Federat	BOGDANOV A K et al.	C25D 11/02
	Q	WO0225113A	03-2002	World Intellect	HASERT et al.	F04C 18/344
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wu et al., "Effect of Polishing Pretreatment on the Fabrication of Ordered Nanopore Arrays on Aluminum Foil by Anodization", J. Vac. Sci. Technol., Vol. B 20(3), May/June 2002, pp. 776-782.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.